

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2851
Examiner: Rodney E. Fuller
Confirmation No.: 7307

In Re PATENT APPLICATION Of:

Applicant: Toshiharu Furukawa, et al.

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Serial No.: 10/829,623

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Filed: April 22, 2004

) **AMENDMENT**

For: WAFER CELL FOR IMMERSION
LITHOGRAPHY

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Attny Ref.: IBM 231

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April 2, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is in response to the non-final Official Action mailed on January 3, 2007. No fee is due. However, please charge our Deposit Account No. 18-0002 if any fees are needed to enter this paper, and please advise us accordingly. It is noted that no petition is required because of the authorization to charge, but please consider this paper a petition for extension of time if needed.